



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Gary M. Moore  
Assignee: Moore Epitaxial Inc.  
Title: METHOD OF CONTROLLING GAS FLOW TO A SEMICONDUCTOR  
PROCESSING REACTOR  
Serial No.: 09/765,919 Filed: January 18, 2001  
Examiner: Chen, Bret P. Group Art Unit: 1762  
Docket No.: MTEC101001

Monterey, CA  
November 6, 2002

Assistant Commissioner for Patents  
Washington, D.C. 20231

AMENDMENT

Dear Sir:

In response to the Office Action dated August 6, 2002,  
enclosed herewith are:

1. A separate paper entitled "Clean Copy of  
Description Replacement Paragraphs" with a clean version  
of each replacement paragraph in the specification along  
with a clear instruction for entry (3 pages); and
2. A separate paper entitled "Version with Markings  
to Show Changes Made" with markings to show amendments to  
the specification (4 pages).

The above papers are incorporated herein by reference in their  
entireties as a part of this paper.

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